

GAPCHUL LEE Conflict and Reaction

NOVEMBER 6 - DECEMBER 5, 2009



abg

andrew bae gallery

CONTEMPORARY ASIAN ART

300 WEST SUPERIOR STREET CHICAGO ILLINOIS 60654

TUESDAY THROUGH SATURDAY 10AM TO 6PM

ANDREWBAEGALLERY.COM 312.335.8601



GAPCHUL LEE

Conflict and Reaction

front NAMHAE 94-1 PHOTOGRAPHY, GELATIN-SILVER PRINT 16.5 X 11 IN. ED 25, 1994

this page GYEONGJU 05-1 PHOTOGRAPHY, GELATIN-SILVER PRINT 11 X 16.5 IN.ED 25, 2005 NOVEMBER 6 – DECEMBER 5, 2009 OPENING RECEPTION FRIDAY NOVEMBER 6, 5 – 8 PM Photographer Gapchul Lee has obsessively documented Korean Shamanism for nearly 30 years. Unforgivingly frank and daringly swift, his camera acts rather on instinct and freezes prayers' moments in its most tense compositions; its out-of-focus foregrounds, its offset angles and, above all, its strangely visceral and beautiful vulnerability. In Lee's frames, men are at their weakest in seeking the divine. With deep, gritty humanism that exalts man's empathy, suffering and emotion at its core, Lee's ominous and romantic photography finds universality within the proximity of human warmth. Please join us at the opening of the photographer's first show in America.

THE EXHIBITION CONFLICT AND REACTION IS ORGANIZED WITH THE COOPERATION OF KOREAN CONSULATE GENERAL IN CHICAGO AND SEJONG CULTURAL SOCIETY.